

(PTO Form 1449 modified)

APP/1931.P1

10/052,681

**SUPPLEMENTAL LIST OF PATENTS AND PUBLICATIONS
CITED BY APPLICANT**

Applicant

Confirmation No.:

Xi, et al.

4083

(Use several sheets if necessary)

Filing Date

01/17/2002

Examiner Unknown

OTHER ART*Examiner
Initial

Including Author, Title, Date, Pertinent Pages, Etc.

C1

K. Min et al., "Comparative Study of Tantalum and Tantalum Nitride as a Diffusion Barrier for CU Metallization" J. Vac. Sc. Technol. B 14(5), Sept/Oct 1996, p 1-7.

C2

International Search Report for PCT/US01/26751, dated May 27, 2002.

C3

International Search Report for PCT/US01/24880, dated May 17, 2002.

C4

International Search Report for PCT/US98/09751, dated September 16, 1998.

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6/11/03

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